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RESPONSE UNDER 37 C.F.R.
§1.116 EXPEDITED PROCEDURE
EXAMINING GROUP 2812

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Haruo Sunakawa, et al.

Examiner: S. Mulpuri

Serial No.: 09/821,411

Group Art Unit: 2812

Filed: March 29, 2001

Docket: 14463

For: METHOD OF MANUFACTURING A
NITROGEN-BASED SEMICONDUCTOR
SUBSTRATE AND A SEMICONDUCTOR
ELEMENT BY USING SAME

Dated: March 26, 2003

Commissioner for Patents
Washington, D.C. 20231

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U.S. PATENT & TRADEMARK OFFICE

RESPONSE UNDER 37 C.F.R. §1.116

Sir:

In response to the Office Action dated November 26, 2002, applicants submit the following Remarks for entry in the above-identified case.

REMARKS

The Office Action has rejected Claims 10-20 under 35 U.S.C. §103(a) as defining subject matter which is allegedly rendered obvious by the teachings in U.S. Patent No. 6,239,033 to Kawai ("Kawai") in view of U.S. Patent No. 5,834,325 to Motoki, et al.

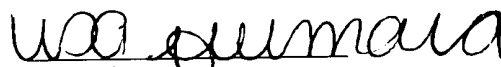
03/26/2003 ASMITH 00000001 191013 09821411
01 FC:1251 ("Motoki, et al.").
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It is respectfully submitted that the present application is in condition for allowance in view of the following Remarks. Favorable consideration is respectfully requested.

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that this paper is being facsimile transmitted to the Patent and Trademark Office on the date shown below.

Dated: March 26, 2003


Lisa Fiumara

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